

	L #	Hits	Search Text	DBs
1	L1	9132	(phase adj (shift or shifting)).clm.	USPAT
2	L2	3440	1 and (cmp) or (chemical adj mechanical adj polishing)	USPAT
3	L4	39	1 and ((CMP) OR (CHEMICAL ADJ MECHANICAL ADJ POLISHING))	USPAT
4	L5	257	(1 AND (resist.clm. or photoresist.clm.))	USPAT